

Electronic Acknowledgement Receipt

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Application Number:	10783057
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Title of Invention:	Apparatus and method for managing liquid crystal substrate
First Named Inventor:	Tadayuki Fujiwara
Customer Number:	40854
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Transmittal letter	15369-Ltr.PDF	275592	no	5

Warnings:					
Information:					
2	Information Disclosure Statement (IDS) Filed	15369-IDS.pdf	709180	no	4
Warnings:					
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3	Foreign Reference	15639-Ref1.PDF	241829	no	10
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